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PATENT

Honeywell's Docket No. 30-4885 (4780)  
Practitioner's Docket No. 51-052-001

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**Box Non-Fee Amendment  
Assistant Commissioner for Patents  
Washington, D.C. 20231**

**POWER OF ATTORNEY BY ASSIGNEE OF ENTIRE INTEREST  
(REVOCATION OF PRIOR POWERS)**

As assignee of record of the entire interest of the above identified application,

**REVOCATION OF PRIOR POWERS OF ATTORNEY**

all powers of attorney previously given are hereby revoked and

**NEW POWER OF ATTORNEY**

the following practitioner is hereby appointed to prosecute and transact all business in the Patent and Trademark Office connected therewith.

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Application No.	Filing Date	Title	Reel/Frame No.	Status
09/741634	12/19/2000	ELK Dielectric Materials With Layered Structure	011404/0606	Pending
09/860993	05/17/2001	Hardmask for Electronic Applications	011838/0670	Pending
09/545058	04/07/2000	Low Dielectric Constant Organic Dielectrics Based on Cage-Like Structures	010725/0813	Issued
09/902924	07/10/2001	Low Dielectric Constant Organic Dielectrics Based on Cage-Like Structures	010725/0813	Pending
10/293024	11/12/2002	Low Dielectric Constant Organic Dielectrics Based on Cage-Like Structures	010725/0813	Pending
09/618945	07/19/2000	Compositions and Methods for Thermosetting Molecules in Organic Compositions	011294/0174	Issued
10/176335	06/19/2002	Compositions and Methods for Thermosetting Molecules in Organic Compositions	011294/0174	Pending
10/267380	10/08/2002	Compositions and Methods for Thermosetting Molecules in Organic Compositions	011294/0174	Pending
09/587851	06/06/2000	Low Dielectric Constant Nano Composites	011075/0072	Issued
10/189318	07/03/2002	Low Dielectric Constant Nano Composites	011075/0072	Pending
Not Assigned Yet	03/13/2003	Low Dielectric Constant Nano Composites	011075/0072	Pending
09/792606	02/22/2001	Porous Low Dielectric Constant Film Made Using Hollow Polymer Particles	011570/0776	Allowed

10/339958	01/09/2003	Porous Low Dielectric Constant Film Made Using Hollow Polymer Particles	011570/0776	Pending
09/671022	09/26/2000	Reducing the Dielectric Constant of Flare Via Photogenerated Porosity	011184/0078	Issued
09/619237	07/19/2000	Low Dielectric Constant Materials With Polymeric Networks	011235/0828	Issued
10/004584	12/03/2001	Low Dielectric Constant Materials With Polymeric Networks	011235/0828	Pending
09/761529	01/11/2001	Colloidal Silica Composite Films for Premetal Dielectric Applications	011876/0745	Issued
10/188433	07/03/2002	Colloidal Silica Composite Films for Premetal Dielectric Applications	011876/0745	Pending
09/825380	04/02/2001	Smart Container for Bulk Delivery	011680/0042	Pending
10/263,204	10/01/2002	Enhancement of Thermomechanical Properties	Assignment not filed yet	Pending
09/943237	08/29/2001	CVD and Spin-On Process for Shallow Trench Isolation	012146/0238	Pending
09/768439	01/23/2001	Viscous Protective Overlayers For Planarization	011904/0977	Pending
09/205006	12/02/1998	Novolac Polymer Planarization Films With High Temperature Stability	9621/0857	Issued
09/735838	12/12/2000	Novolac Polymer Planarization Films With High Temperature Stability	9621/0857	Issued
09/735746	12/12/2000	Novolac Polymer Planarization Films With High Temperature Stability	9621/0857	Allowed
10/299127	12/18/2002	Novolac Polymer Planarization Films With High Temperature Stability	9621/0857	Pending
09/227035	01/07/1999	Dielectric Films From Organohydridosiloxane Resins With Low Organic Content	9698/0261	Issued
09/609437	06/30/2000	Dielectric Films From Organohydridosiloxane Resins With Low Organic Content	9698/0261	Issued
09/227498	01/07/1999	Dielectric Films From Organohydridosiloxane Resins With High Organic Content	9699/0648	Issued
09/609499	06/30/2000	Dielectric Films From Organohydridosiloxane Resins With High Organic Content	9699/0648	Issued

08/665189	06/14/1996	Process for Making Hydroxy-Substituted Ethynylated Biphenyl Compounds	Assignment information not in file	Issued
09/561387	04/27/2000	Reactive Aqueous Metal Oxide Sols As Polishing Slurries for Low Dielectric Constant Materials	010778/0978	Issued
10/214677	08/07/2002	Reactive Aqueous Metal Oxide Sols As Polishing Slurries for Low Dielectric Constant Materials	010778/0978	Pending
09/235141	01/21/1999	Solvent Systems For Low Dielectric Constant Polymeric Materials	9907/0307	Issued
09/340976	06/28/1999	Solvent Systems For Low Dielectric Constant Polymeric Materials	9907/0307	Issued
10/143039	05/07/2002	Solvent Systems For Low Dielectric Constant Polymeric Materials	9907/0307	Issued
10/299320	11/18/2002	Solvent Systems For Low Dielectric Constant Polymeric Materials	9907/0307	Pending
09/160514	09/24/1998	Oxidizing Polishing Slurries For Low Dielectric Constant Materials	9813/0001	Issued
09/882000	06/14/2001	Oxidizing Polishing Slurries For Low Dielectric Constant Materials	9813/0001	Pending
08/665132	06/14/1996	Poly (Arylene Ether) Compositions and the Method for Their Manufacture	8190/0680	Issued
09/659380	09/08/2000	Poly (Arylene Ether) Compositions and the Method for Their Manufacture	8190/0680	Issued
08/271291	07/06/1994	Novolac Polymer Planarization Films For Microelectronic Structures	01024/0036	Issued
09/055516	04/06/1998	Synthesis of Hydrogensilsesquioxane and Organohydridosiloxane Resins	Assignment not available at this time	Issued
09/698883	10/27/2000	Spin-On Glass Anti-Reflective Coating For Photolithography	010245/0036	Issued
09/330248	11/13/2000	Spin-On Glass Anti-Reflective Coating For Photolithography	010245/0036	Issued
10/012649	11/5/2001	Spin-On Glass Anti-Reflective Coating For Photolithography	010245/0036	Pending
10/001143	11/15/2001	Spin-On Glass Anti-Reflective Coating For Photolithography	010245/0036	Pending
09/491166	01/26/2000	Spin-On Glass Anti-Reflective Coating For Photolithography	010245/0036	Issued
10/300357	11/19/2002	Spin-On Glass Anti-Reflective Coating For Photolithography	010245/0036	Pending

10/076,846	02/14/2002	Spin-On Glass Anti-Reflective Coating For Photolithography	010245/0036	Pending
09/356487	07/19/1999	Compositions and Processes For Spin Etch Planarization	010117/0691	Pending
10/222230	08/15/2002	Compositions and Processes For Spin Etch Planarization	010117/0691	Pending
09/055244	04/06/1998	Synthesis of Siloxane Resins	Assignment not available at this time	Issued
09/505314	02/16/2000	Synthesis of Siloxane Resins	Assignment not available at this time	Pending
09/745266	12/20/2000	Composition for Chemical Mechanical Planarization of Copper, Tantalum, and Tantalum Nitride	010117/0800	Allowed
09/357264	07/19/1999	Composition for Chemical Mechanical Planarization of Copper, Tantalum, and Tantalum Nitride	010117/0800	Pending
08/489424	06/12/1996	Silicon Carboxide Composite Reinforced With Ceramic Fibers Having A Surface Enriched in Boron Nitride	Assignment not available at this time	Issued
09/590770	06/08/2000	Chemical Hydrodynamic Etch Planarization	011980/0176	Pending
09/547167	04/11/2000	Use of Sacrificial Inorganic Dielectrics for Dual Damascene Processes. . .	012734/0060	Pending
09/390143	09/03/1999	Photoresist Ashing Process for Organic and Inorganic Polymer. . .	Assignment not available at this time	Issued
09/417257	10/12/1999	Environment Controlled WIP Cart	Assignment not available at this time	Issued
09/422039	10/20/1999	Complex-Shaped Fiber for Particle and Molecular Filtration	010684/0327	Issued
09/833276	04/11/2001	Devices and Methods for Chemical Reactive Filtration	011792/0556	Pending
09/834581	04/12/2001	Devices and Methods for Chemical Reactive Filtration	012266/0121	Pending
09/617365	07/17/2000	Absorbing Compounds for Spin-On-Glass Anti-Reflective Coatings for Photolithography	Assignment not available at this time	Issued
10/012651	11/05/2001	Absorbing Compounds for Spin-	Assignment not	Allowed

		On-Glass Anti-Reflective Coatings for Photolithography	available at this time	
09/547187	04/11/2000	Chemical Mechanical Planarization of Low Dielectric Constant Materials	010757/0060	Issued
10/145649	05/14/2002	Chemical Mechanical Planarization of Low Dielectric Constant Materials	010757/0060	Pending
09/591181	06/08/2000	Edge Bead Removal for Spin-On Materials. . .	011184/0225	Allowed
Serial No. Not Assigned	02/26/2003	Edge Bead Removal for Spin-On Materials. . .	011184/0225	Pending
09/420218	10/18/1999	Deposition of Organosilsesquioxane Films	Assignment not available at this time	Issued
10/150185	05/16/2002	Deposition of Organosilsesquioxane Films	Assignment not available at this time	Pending
09/420052	10/18/1999	Deposition of Fluorosilsesquioxane Films	Assignment not available at this time	Issued
10/150445	5/16/2002	Deposition of Fluorosilsesquioxane Films	Assignment not available at this time	Pending
09/197478	11/20/1998	Poly (Arylene Ether) Homopolymer Compositions and Methods of Manufacture Thereof	9747/0690	Issued
09/039289	3/12/1998	Stable Inorganic Polymers	9106/0106	Issued
09/044831	04/21/1997	Organohydridosiloxane Resins With Low Organic Content	Assignment not available at this time	Issued
09/610567	07/03/2000	Organohydridosiloxane Resins With Low Organic Content	Assignment not available at this time	Issued
09/044798	03/19/1998	Organohydridosiloxane Resins With High Organic Content	9067/0165	Issued
09/611528	06/30/2000	Organohydridosiloxane Resins With High Organic Content	9067/0165	Issued
10/299349	11/18/2002	Organohydridosiloxane Resins With High Organic Content	9067/0165	Pending
08/990157	12/12/1997	Poly (Arylene Ether) Compositions and Methods of Manufacture Thereof	9635/0730	Issued
09/847766	05/01/2001	Spin-On Planarizers and Metallic Solder Planarizers for SEP	Assignment not available at this time	Pending

09/327356	06/07/1999	Low Dielectric Constant Polyorganosilicon Coatings Generated From Polycarbosilanes	011838/0670	Issued
09/746607	12/20/2000	Low Dielectric Constant Polyorganosilicon Coatings Generated From Polycarbosilanes	011838/0670	Issued
10/122400	04/11/2002	Low Dielectric Constant Polyorganosilicon Coatings Generated From Polycarbosilanes	011838/0670	Pending
09/471299	12/23/1999	Hydridopolycarbosilane	010467/0172	Allowed
10/163144	06/04/2002	Hydridopolycarbosilane	010467/0172	Pending
09/420091	10/18/1999	Solvents for Processing Silsesquioxane and Siloxane Resins	Assignment not available at this time	Issued
09/145921	09/03/1998	Method for Cleaning Organic Dielectric Film Containing Semiconductor Wafers	944/0152	Issued
09/538276	03/30/2000	Nanoporous Polymers Having Backbones With Reactive Groups Employed In Cross-Linking	010724/0678	Issued
09/544722	04/06/2000	Nanoporous Polymers Crosslinked Via Cyclic Structures	Assignment not available at this time	Issued
09/544723	04/06/2000	Nanoporous Material Fabricated Using Polymeric Template Strands	Assignment not available at this time	Issued
09/544504	04/06/2000	Nanoporous Polymers Comprising Macrocycles	010723/0363	Issued
09/420611	10/18/1999	Nanoporous Material Fabricated Using A Dissolvable Phase	Assignment not available at this time	Issued
09/420042	10/18/1999	Infiltrated Nanoporous Materials and Methods of Producing The Same	Assignment not available at this time	Issued
09/651396	08/29/2000	Infiltrated Nanoporous Materials and Methods of Producing Same	Assignment not available at this time	Pending
09/512971	02/24/2000	Alignment Plate with Matched Thermal Coefficient of Expansion	010640/0663	Allowed
10/238800	09/09/2002	Alignment Plate with Matched Thermal Coefficient of Expansion	010640/0663	Pending

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